

Sustainability of semiconductor manufacturing

Manufacturing Energy Efficiency and Sustainability (MEES) Group

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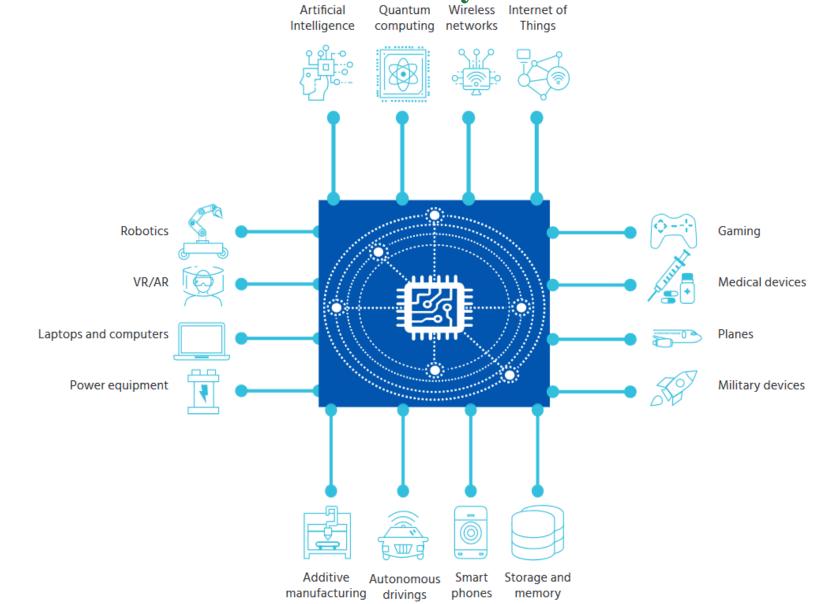
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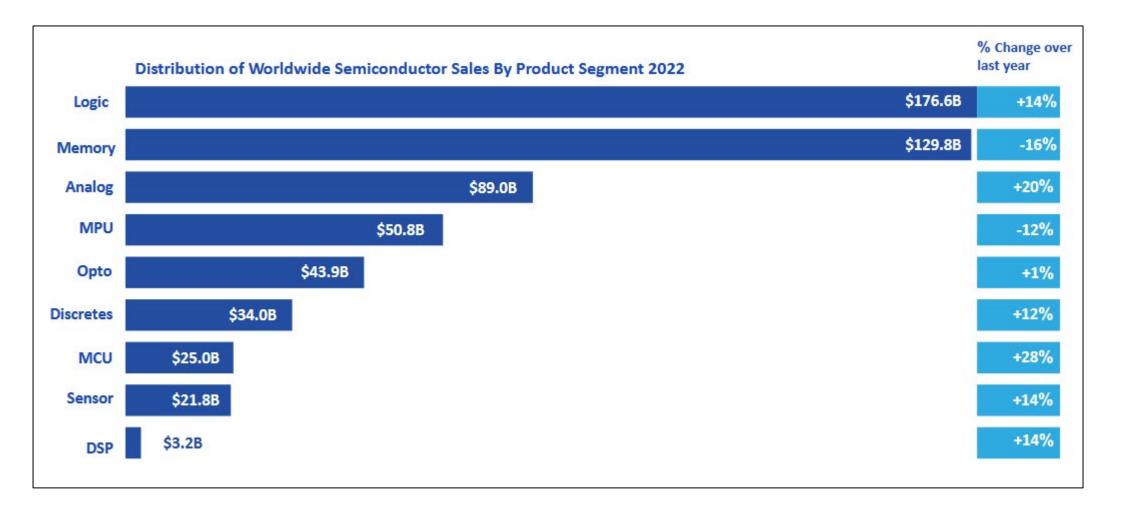
What are semiconductors & where are they used in?



Semiconductors are small integrated circuits (ICs) or microchips that used widely in many information and communication technology (ICT) devices that we use today CAK RIDGE

Image source: A. Capri, Hinrich foundation, Semiconductors at the heart of the US-China tech war, 2020.

Global semiconductor sales by type in 2022



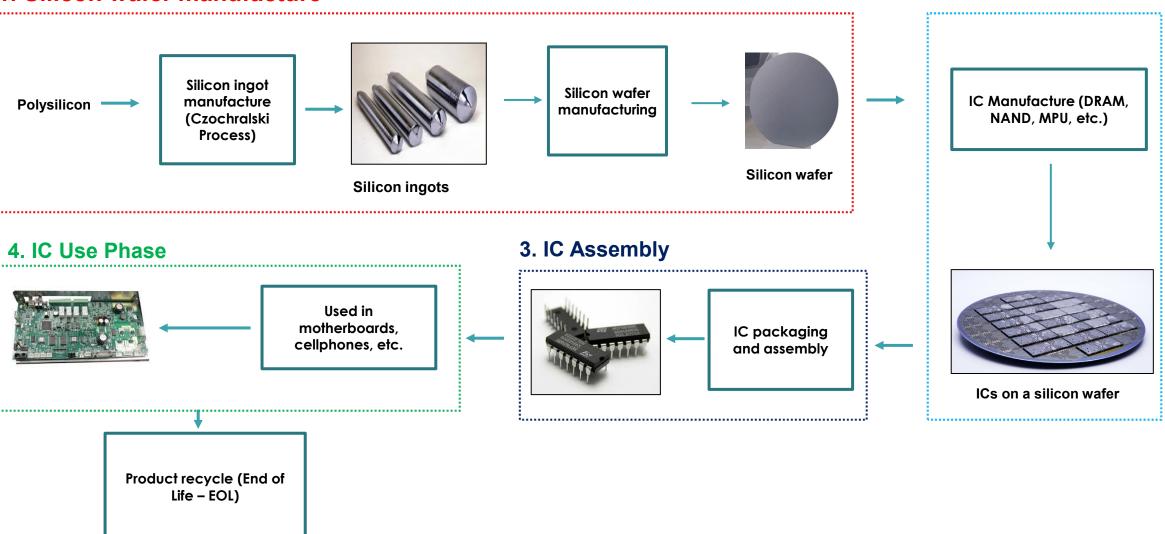
Semiconductor market is dominated by logic and memory ICs with their combined share exceeding >50%.

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Life cycle of an integrated chip (IC)

1. Silicon wafer manufacture

Oak Ridge



IC life cycle is complex - Four stages - Silicon wafer manufacture, IC manufacture, use, end of life

2. IC Manufacture

National Laboratory Nagapurkar, Prashant, and Das, Sujit. Economic and embodied energy analysis of integrated circuit manufacturing processes. United States: N. p., 2022. Web doi:10.1016/j.suscom.2022.100771.

Why focus on sustainability integrated circuits (IC) within devices?

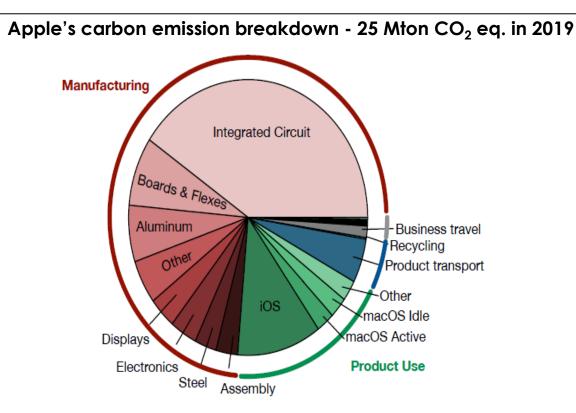
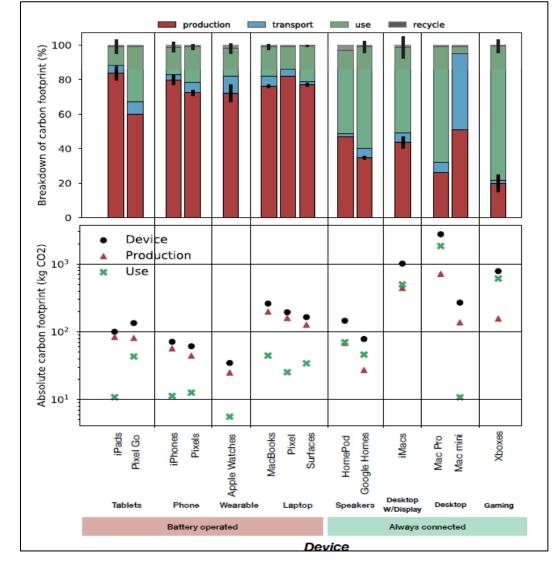


Fig. 5. Apple's carbon-emission breakdown. In aggregate, the hardware life cycle (i.e., manufacturing, transport, use, and recycling) comprises over 98% of Apple's total emissions. Manufacturing accounts for 74% of total emissions, and hardware use accounts for 19%. Carbon output from manufacturing integrated circuits (i.e., SoCs, DRAM, and NAND flash memory) is higher than that from hardware use.



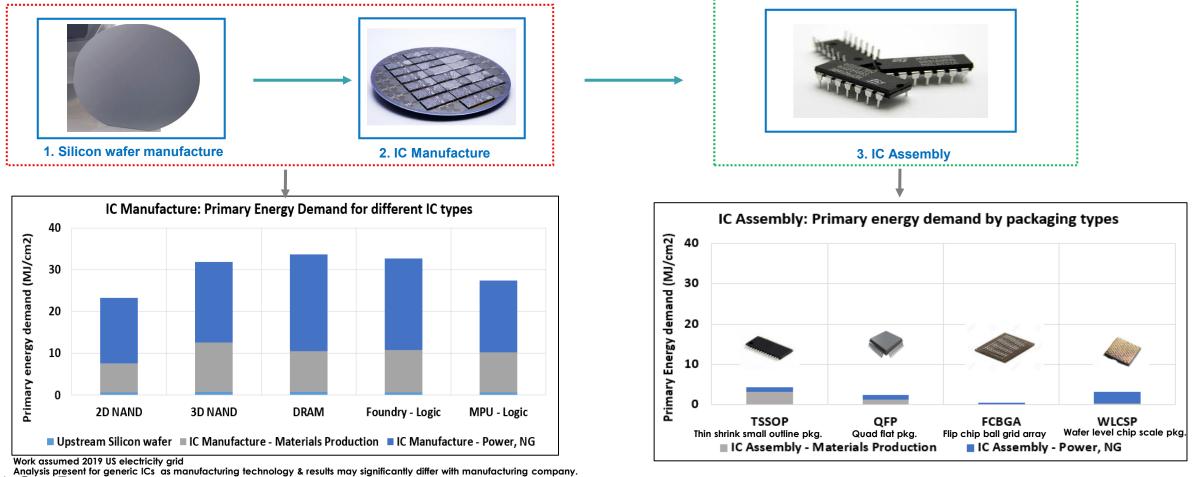
Manufacturing phase (typically for ICs) dominate emissions relative to use phase for battery operated devices. Reverse true for always ON devices.

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Source: U. Gupta, et al., "Chasing Carbon: The Elusive Environmental Footprint of Computing," in 2021

ORNL work - IC manufacture, Assembly Results: Primary energy demand by different types Using harmonization of studies, bill of materials for IC Manufacture, Assembly were inserted into OpenLCA software to compute primary energy demand.

- For ICs of similar technology node (~20 nm), Primary Energy Demand of IC manufacture phase is six times as IC assembly phase.
- Primary energy depended on IC manufacturing process, company (not all companies have identical IC manufacturing process) and final packaging type (QFP, TSSOP, etc.).

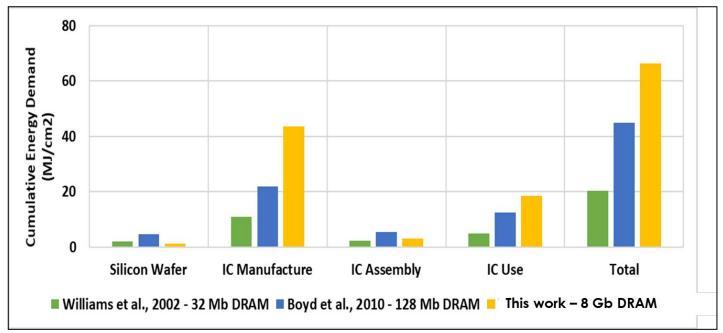


DAK KIDGE National Laboratory Primary energy demand of IC manufacture ~ 6X as that of IC assembly phase en slide master to edit

ORNL Work done by Prashant Nagapurkar, Sachin Nimbalkar, Sujit Das

ORNL work – Life cycle energy assessment via different DRAM IC stages

- For a representative DRAM IC, primary energy demand was computed over its entire life cycle (Silicon wafer, IC manufacture, assembly, use phase).
- IC Manufacture has the largest share of energy footprint 66% while use phase possessed small 28% share.



In entire life cycle of DRAM – IC manufacture phase has 2/3rd energy share; use phase has <1/3rd.

Nagapurkar, Prashant, and Das, Sujit. Economic and embodied energy analysis of integrated circuit manufacturing processes. United States: N. p., 2022. Web. doi:10.1016/j.suscom.2022.100771.

E. D. Williams, R. U. Ayres, and M. Heller, "The 1.7 Kilogram Microchip: Energy and Material Use in the Production of Semiconductor Devices," *Environ. Sci. Technol.*, vol. 36, no. 24, pp. 5504–5510, Dec. 2002.

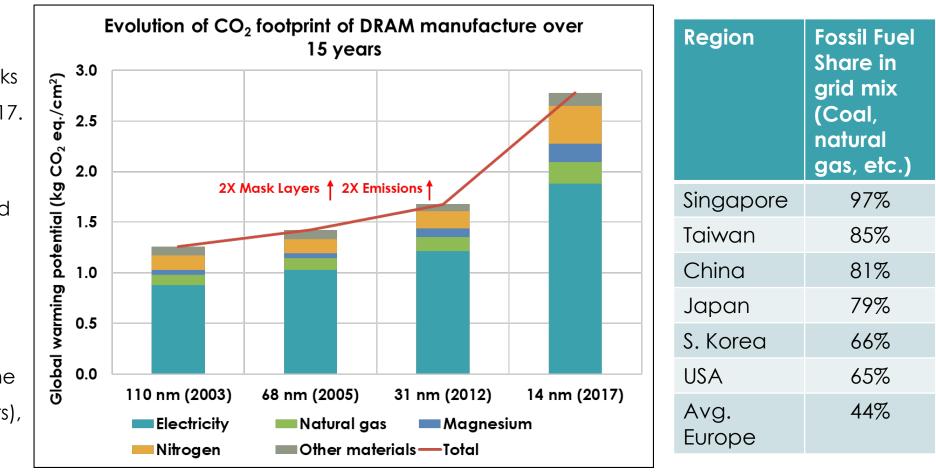
Boyd, Sarah B. "Life-Cycle Assessment of Dynamic Random Access Memory." Life-Cycle Assessment of Semiconductors. Springer, New York, NY, 2012. 97-107.



ORNL Work done by Prashant Nagapurkar, Sachin Nimbalkar, Sujit Das

ORNL work – IC manufacturing footprint increasing over time

- 2X increase in CO_2 emissions due to 2X increase in photomasks from years 2003 to 2017.
- Increase in # of photomasks increased the electricity consumption.
- Newer the manuf. technology (Higher the number of mask layers), larger is the CO2 footprint.



Work assumed 2019 US electricity grid

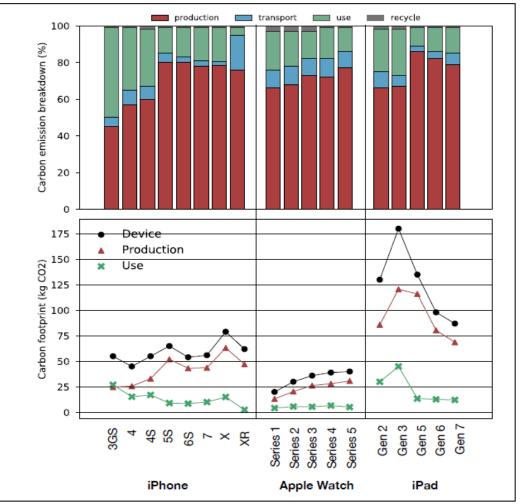
Analysis present for generic DRAM as DRAM's manufacturing technology may significantly differ by manufacturing company.

The manufacturing share of CO_2 eq. emissions have been increasing with the introduction of newer gen. DRAMs – Location of factory may play key role. **CAK RIDGE** National Laboratory

ORNL Work done by Prashant Nagapurkar, Sachin Nimbalkar, Sujit Das

Do technology advancement really increase manufacturing carbon footprint? – What does literature say?

- Emissions share of production and manufacturing increased from generation to generation.
- For iPhones, manufacturing accounts for 45% of emissions in the 3GS and 75% in the XR;
 - For Apple Watches, 60% in Series 1 and
 75% in Series 5;
 - For iPads, 60% in Gen2 and 75% in Gen 7.
- Hardware provides more flops, memory bandwidth, storage, application support, and sensors.



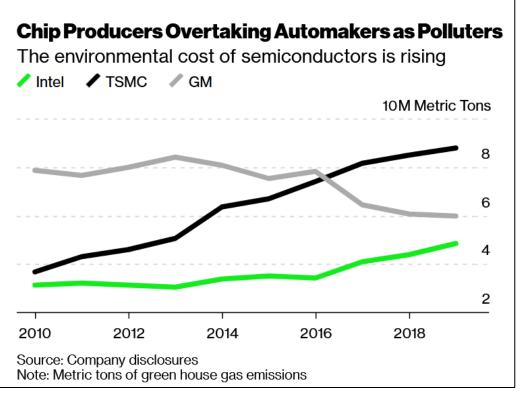
The manufacturing share of CO₂ eq. emissions have been increasing with the introduction of newer gen devices – Use phase share is same or decreasing.

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Source: U. Gupta, et al., "Chasing Carbon: The Elusive Environmental Footprint of Computing," in 2021

Growing importance of environmental impacts of semiconductor manufacturing

CO₂ footprint



Pollution & energy consumption could be correlated given high penetration of fossil sources (coal, natural gas) in electricity grid mix

Intel's share of renewable electricity was 82% in 2020 & is projected to be 100% by 2030. TSMC goal – 25% by 2030 & 100% by 2050.

Water footprint **TSMC's Thirsty Chip Plants** Water use in chipmaking up fivefold in a decade 200.0M Cubic Meters 150.0 100.0 50.0 0

2014

2016

2018

The water footprint and CO₂ eq. emissions of semiconductor manufacturing have been increasing over The water footprint and CO₂ eq. emissions of semiconductor manufacturing have been increasing over time.

2009

2012



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Source: https://www.bloomberg.com/news/articles/2021-04-08/the-chip-industry-has-a-problem-with-its-giant-carbon-footprint

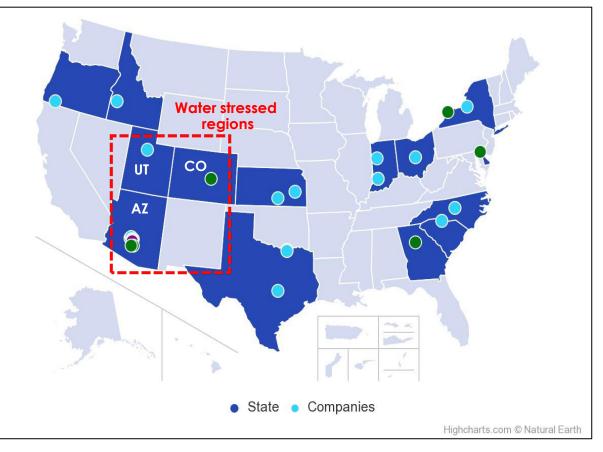
Upcoming new facilities in water stressed US regions

Baseline Water Stress 1. Low (<10%) 2. Low to medium (10-20%) 3. Medium to high (20-40%) 4. High (40-80%) 5. Extremely high (>80%) Arid & low water use No data Esri HERE, DeLorme, MapmyIndia, ©

Baseline water stress in the US

National Laboratory

Upcoming manufacturing facilities coming up

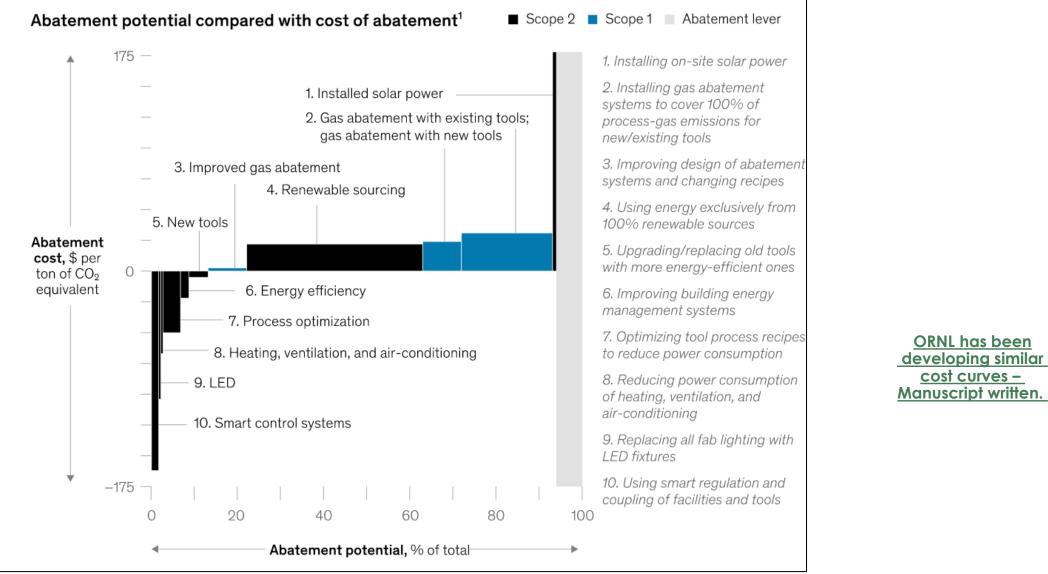


 Semiconductors Equipment Materials Outversity R&D Partner

A total of 13 manufacturing facilities (1 TSMC foundry in AZ) coming up in water stressed region of AZ & CO. **CAK RIDGE**

Kehl et al. 2020 DOI: https://doi.org/10.22158/ees.v3n2p1; https://www.semiconductors.org/u-s-semiconductor-ecosystem-map/

Cost effective solutions to decarbonize semiconductor manufacturing



CO₂ abatement costs vary. Renewable electricity purchase most widely used option along with installation of PFC abatement tools

https://www.mckinsey.com/industries/semiconductors/our-insights/sustainability-in-semiconductor-operations-toward-net-zero-production

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Conclusions & Future work

- Manufacturing energy of IC is an energy and environmental hotspot in the entire life cycle of the device.
- Manufacturing energy footprint and likely emissions of ICs have been increasing due to advancement in technology generations & complex manufacturing process.
- High water demand of fabs can be a concern particularly in water stressed states such as Colorado and Arizona.
- More analysis & data is needed for advanced generation of ICs (<5nm)
 - Lack of facility level data for emissions, energy, water footprint for advanced technology nodes (<5nm).
 - Data by process steps is unavailable.
 - EUV energy consumption.
- Facility level data is crucial to enhance & improve sustainability of CAK RIDGE semiconductor manufacturing.

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